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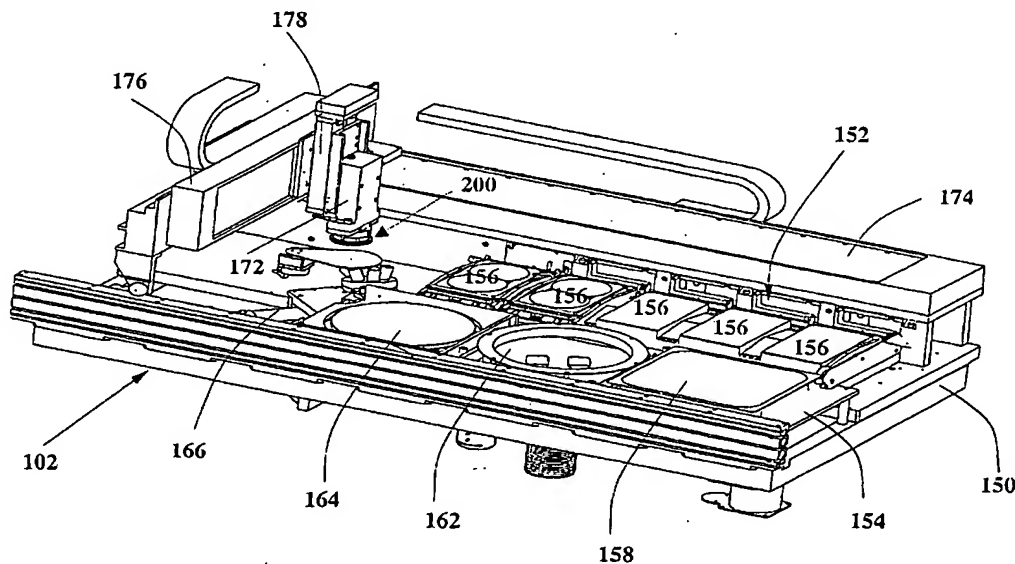
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(54) Title: A SYSTEM AND A METHOD FOR POLISHING OPTICAL CONNECTORS

(57) **Abstract:** A polishing system for polishing optical connectors includes at least one polishing station having a region of polishing film overlying a substrate block, and a polishing fixture (200). The polishing fixture has connector mounting holes (204) for receiving optical connectors and a working liquid supply arrangement including working liquid release channels (210) for directing working liquid to regions adjacent to the connector mounting holes. One or more of the working liquid release channels is interspaced between the connector mounting holes. The polishing system also includes a drive system (174) (176) (178) for generating relative motion between the polishing fixture and the polishing station so as to polish the optical connectors.